

Customer No.: 31561  
Docket No.: 11583-US-PA  
Application No.: 10/708,209

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:	)	
Kuo, Tai-Yu et al.	)	Examiner: Doan, Theresa T
Serial No.: 10/708,209	)	Art Unit: 2814
Filed: 02/17/2004	)	Docket No.: 11583-US-PA
For: Thin Film Transistor Array Substrate	)	
And Photolithography Process And	)	
Design Of The Mask Thereof	)	

No fee is believed to be due in connection with this amendment and response to Office Action. If, however, any fee is believed to be due, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (order No. 11583-US-PA).

**AMENDMENTS AFTER NOTICE OF ALLOWANCE UNDER 37 CFR 1.312**

United States Patent and Trademark Office  
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Mail Stop **AF**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

The Notice of Allowability dated 02/10/2005, has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.

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It's OK to enter  
TD  
05/26/05